L	Hits	Search Text	DB	Time stamp
Number		•		
1	119375	(semiconductor adj wafer)	USPAT;	2004/09/29
			US-PGPUB;	19:51
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
2	36133	((semiconductor adj wafer)) and	USPAT;	2004/09/29
		support\$3	US-PGPUB;	19:52
			EPO; JPO;	
İ			DERWENT;	
			IBM_TDB	
3	561	(((semiconductor adj wafer)) and	USPAT;	2004/09/29
		support\$3) and (crystal adj orientation)	US-PGPUB;	19:53
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	l
4	468		USPAT;	2004/09/29
		support\$3) and (crystal adj orientation))	US-PGPUB;	19:54
		and (mark or notch or line)	EPO; JPO;	
			DERWENT;	
			IBM_TDB	